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Name: National Science FoundationInternal Address: Office of the General Counsel
Suite 1265Street Address: 4201 Wilson BoulevardCity: Arlington State: VA Zip: 22230Additional name(s) & address(es) attached? ☐ Yes ☒ No

4. Application number(s) or patent number(s):

If this document is being filed together with a new application, the execution date of the application is: _____

A. Patent Application No.(s) 09/699,117

B. Patent No.(s) _____

Additional numbers attached? ☐ Yes ☒ No

5. Name and address of party to whom correspondence concerning document should be mailed:

Name: Robin Clay FritschInternal Address: Office of the General CounselSuite 1625Street Address: 4201 Wilson BoulevardCity: Arlington State: VA Zip: 222306. Total number of applications and patents involved: ☐7. Total fee (37 CFR 3.41).....\$ 0.00☐ Enclosed☐ Authorized to be charged to deposit account

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Robin Clay Fritsch

Name of Person Signing

Signature

03/28/02

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This instrument confirms to the United States Government, as represented by the NATIONAL SCIENCE FOUNDATION, an irrevocable, nonexclusive, nontransferable, royalty-free license to practice or have practiced on its behalf throughout the world the following subject invention:

Title: Method of Electroplating of High Aspect Ratio Metal Structures into Semiconductors

Inventor(s): Axel Scherer and Joyce Wong

Patent App Type: Nonprovisional

Serial No.: 09/699,117

Filing Date: 10/27/00

NSF Grant No: ECS-9632937

The subject invention was made with the support of the above grant.

Principal rights to this subject invention have been left with the licensor.

Dated: March 2, 2001

CALIFORNIA INSTITUTE OF TECHNOLOGY



Adam Cochran
The Intellectual Property Counsel

Dated:

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Accepted on behalf of NSF

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